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| | | | | Application Number | 10/808,353 |
| | | | | Filing Date | March 25, 2004 |
| | | | | First Named Inventor | Hongyong ZHANG et al. |
| | | | | Group Art Unit | |
| | | | | Examiner Name | |
| Sheet | 1 | of | 1 | Attorney Docket Number | 0756-7272 |

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

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| MMU | JP | 03-227525 | | | 10/08/1991 | | Abst. |
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| Examiner Signature | M.Wilczewski | Date Considered | 12/05 |
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| | | | | Application Number | Based on 09/222,185 |
| | | | | Filing Date | December 29, 1998 |
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| | | | | Group Art Unit | 2822 |
| | | | | Examiner Name | Mary Wilczewski |
| Sheet | 1 | of | 4 | Attorney Docket Number | 0756-7272 |

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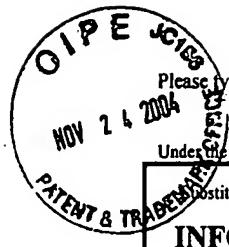
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| <p>ABERDEEN Institute for form 1449A/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p><i>(use as many sheets as necessary)</i></p> | | | | <p><i>Complete if Known</i></p> <table border="1"> <tr> <td>Application Number</td> <td>10/808,353</td> </tr> <tr> <td>Filing Date</td> <td>March 25, 2004</td> </tr> <tr> <td>First Named Inventor</td> <td>Hongyong ZHANG et al.</td> </tr> <tr> <td>Group Art Unit</td> <td>2811</td> </tr> <tr> <td>Examiner Name</td> <td></td> </tr> <tr> <td colspan="2">Attorney Docket Number</td> </tr> </table> | | Application Number | 10/808,353 | Filing Date | March 25, 2004 | First Named Inventor | Hongyong ZHANG et al. | Group Art Unit | 2811 | Examiner Name | | Attorney Docket Number | |
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| Examiner Name | | | | | | | | | | | | | | | | | |
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